

Confirmation No.6431

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:	PONOMAREV	Examiner:	Whalen, D.
Serial No.:	10/596,422	Group Art Unit:	4176
Filed:	June 13, 2006	Docket No.:	NL031497
Title:	METHOD FOR FORMING A STRAINED SI-CHANNEL IN A MOSFET STRUCTURE		

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**AMENDMENT AND RESPONSE**

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Customer No. <b>65913</b>
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Dear Sir:

In response to the non-final Office Action dated October 29, 2007, please reconsider the application in view of the following amendments and remarks.

A complete listing of the claims, to include any amendments presented therein, begins on page 2 of this paper.

Remarks/Arguments follow on page 5.

**Authorization is provided to charge/credit Deposit Account 50-0996 (NXPS.392PA) any requisite fees/overages to enter this paper.**